Search Notes			

Application No.	Applicant(s)	
10/018,686	ONISHI ET AL.	
Examiner	Art Unit	
Michael V Battaglia	2652	

Michael V Battaglia

SEARCHED			
Class	Subclass	Date	Examiner
369	112.01	8/16/2004	MB
	112.29		
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INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
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SEARCH NOT (INCLUDING SEARCH S		')
	DATE	EXMR
(laser ((light radiation) adj (source emit\$4))) with (focus focal) with collimat\$3 with (nearer farther further closer)	8/16/2004	MK
((magnif\$7 with cd\$4) same (magnif\$7 with dvd\$4))	8/17/2004	MB
369/\$7.ccls. and ((second different plural\$3) near3 wave\$1length\$1) and (substrate with (different second ("0.6" "1.2")) with	8/16/2004	MB
<u> </u>		